

STN	Lasery a laserové zariadenia Skúšobné metódy prahu poškodenia spôsobeného laserovým žiarením Časť 1: Definície a všeobecné princípy (ISO 21254-1: 2025)	STN EN ISO 21254-1 19 2022
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Lasers and laser-related equipment - Test methods for laser-induced damage threshold - Part 1: Definitions and general principles (ISO 21254-1:2025)

Táto norma obsahuje anglickú verziu európskej normy.
This standard includes the English version of the European Standard.

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Lasers and laser-related equipment - Test methods for laser-induced damage threshold - Part 1: Definitions and general principles (ISO 21254-1:2025)

Lasers et équipements associés aux lasers - Méthodes d'essai du seuil d'endommagement provoqué par laser - Partie 1: Définitions et principes de base (ISO 21254-1:2025)

Laser und Laseranlagen - Prüfverfahren für die laserinduzierte Zerstörschwelle - Teil 1: Begriffe und allgemeine Grundsätze (ISO 21254-1:2025)

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EN ISO 21254-1:2025 (E)

Contents	Page
European foreword.....	3

European foreword

This document (EN ISO 21254-1:2025) has been prepared by Technical Committee ISO/TC 172 "Optics and photonics" in collaboration with Technical Committee CEN/TC 123 "Lasers and photonics" the secretariat of which is held by DIN.

This European Standard shall be given the status of a national standard, either by publication of an identical text or by endorsement, at the latest by March 2026, and conflicting national standards shall be withdrawn at the latest by March 2026.

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Endorsement notice

The text of ISO 21254-1:2025 has been approved by CEN as EN ISO 21254-1:2025 without any modification.



International Standard

ISO 21254-1

Lasers and laser-related equipment — Test methods for laser-induced damage threshold —

Part 1: Definitions and general principles

*Lasers et équipements associés aux lasers — Méthodes d'essai du
seuil d'endommagement provoqué par laser —*

Partie 1: Définitions et principes de base

**Second edition
2025-08**

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Contents

Page

Foreword	v
Introduction	vi
1 Scope	1
2 Normative references	1
3 Terms and definitions	1
3.1 Terms and definitions	2
3.2 Symbols and units of measurement	3
4 Units of laser irradiation, LIDT and pertinent units	4
5 Laser damage, damage threshold and associated criteria	4
5.1 General laser damage criteria	4
5.1.1 General	4
5.1.2 Classical criterion of laser-induced damage	5
5.1.3 Functional criterion of laser-induced damage	5
5.1.4 Failure mode	5
5.1.5 Laser-induced damage threshold (LIDT)	5
5.1.6 Functional laser-induced damage threshold (F-LIDT)	5
5.1.7 Method of damage threshold calculation	5
5.2 Techniques of laser damage interrogation and related terms	5
5.2.1 General	5
5.2.2 Classical 1-on-1 test	6
5.2.3 Classical S-on-1 test	6
5.2.4 Functional R(S)-on-1 test	6
5.2.5 Functional raster scan test	6
5.2.6 Acceptance test “pass-fail”	6
5.2.7 Laser-induced fatigue	6
5.2.8 Characteristic damage curve or fatigue curve	6
5.2.9 Laser-induced conditioning	6
5.2.10 Conditioning curve	7
5.3 Parameters of testing, sampling and reporting	7
5.3.1 Typical pulse	7
5.3.2 Laser irradiation level, L	7
5.3.3 Maximum irradiation dose	7
5.3.4 Applied irradiation dose	7
5.3.5 Target plane	7
6 Sampling	7
7 Test methods	8
7.1 Principle	8
7.2 Apparatus	9
7.2.1 Laser	9
7.2.2 Variable attenuator and beam delivery system	9
7.2.3 Focusing system	9
7.2.4 Specimen holder	10
7.2.5 Damage detection and inspection systems	10
7.2.6 Beam diagnostic unit	10
7.3 Preparation of specimens for testing	13
7.4 Procedure	14
8 Accuracy of peak irradiation level	15
8.1 General	15
8.2 Relative standard deviation of peak fluence	15
8.3 Relative standard deviation of peak irradiance	15
8.4 Relative standard deviation of linear power density	16
8.5 Relative standard deviation of average peak irradiance	16

ISO 21254-1:2025(en)

9	Test report	17
	Annex A (normative) General usage notes	19
	Bibliography	29

ISO 21254-1:2025(en)**Foreword**

ISO (the International Organization for Standardization) is a worldwide federation of national standards bodies (ISO member bodies). The work of preparing International Standards is normally carried out through ISO technical committees. Each member body interested in a subject for which a technical committee has been established has the right to be represented on that committee. International organizations, governmental and non-governmental, in liaison with ISO, also take part in the work. ISO collaborates closely with the International Electrotechnical Commission (IEC) on all matters of electrotechnical standardization.

The procedures used to develop this document and those intended for its further maintenance are described in the ISO/IEC Directives, Part 1. In particular, the different approval criteria needed for the different types of ISO document should be noted. This document was drafted in accordance with the editorial rules of the ISO/IEC Directives, Part 2 (see www.iso.org/directives).

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This document was prepared by Technical Committee ISO/TC 172, *Optics and photonics*, Subcommittee SC 9, *Laser and electro-optical systems*, in collaboration with the European Committee for Standardization (CEN) Technical Committee CEN/TC 123, *Lasers and photonics*, in accordance with the Agreement on technical cooperation between ISO and CEN (Vienna Agreement).

This second edition cancels and replaces the first edition (ISO 21254-1:2011) which has been technically revised.

The main changes are as follows:

- functional damage criteria and functional damage threshold (F-LIDT) are introduced;
- new units of laser irradiation level are introduced;
- two new test protocols are introduced:
 - extension to R(S)-on-1 test;
 - extension to the raster scan test;
- integration of a new section “General usage notes” in [Annex A](#);
- discussion on accuracy of measurement units is extended.

A list of all parts in the ISO 21254 series can be found on the ISO website.

Any feedback or questions on this document should be directed to the user's national standards body. A complete listing of these bodies can be found at www.iso.org/members.html.

ISO 21254-1:2025(en)

Introduction

Optical components are irreversibly damaged above the so-called laser-induced damage threshold (otherwise referred to as LIDT or damage threshold): which is the maximum laser irradiation level at which it is expected that there is zero probability of damage. Below the single-shot damage threshold, a delayed damage event might also develop over time as a consequence of repetitive laser irradiation, the so-called fatigue effect. Alternatively, repeated exposure with increasing laser irradiation can cause an increase in the damage threshold; the so-called conditioning effect. For the vast majority of use cases, the damage tends to develop on optical surfaces. Only on specific occasions will it occur within the bulk. Thus, if not requested or declared otherwise, the laser-induced damage threshold is tested and reported for the entrance surface of the optical component. For optics with high transmittance, damage may first develop at the exit surface or in the bulk without observing a damage of the entrance surface due to radiation field enhancement effects: self-focusing, diffraction or interference with back-reflected radiation. Back surface damage might also feature lower damage thresholds than the entrance surface as a consequence of poor optical quality. In such cases a functional damage threshold testing can be conducted for the exit surface. However, focusing conditions and the functional damage criterion need to be documented in the test report. Environmental contamination by airborne particles, volatile organic compounds, vacuum exposure, and technological imperfections such as nodular defects of coatings, polishing scratches, Beilby layer, sub-surface damage as well as bulk inclusions, dislocations, or inhomogeneities of any other type are also known to affect the performance of an optical component.

Due to a variety of possible failure mechanisms [6-64], the experimentally estimated “damage threshold” is an aggregated feature of optics handling, environmental conditions, material and surface preparation techniques as well as laser-related exposure parameters such as wavelength, spot size, repetition rate, and pulse duration. As a consequence, there is no single procedure, that could universally satisfy all the testing needs for all the types of optical components available. Instead, different damage testing strategies evolved to address particular needs for testing. Various parts of this document are concerned with the determination of irreversible damage of the optical surfaces and the bulk of an optical component under the influence of laser exposure. This document is dedicated to the fundamentals and general principles of the measurement of laser-induced damage thresholds. Based on the apparatus outlined in ISO 21254-1, measurement protocols for damage testing (1-on-1, S-on-1, R(S)-on-1, and Raster scan) are described in ISO 21254-2, and acceptance testing is described in ISO 21254-3. Recommendations and associated risks pertinent to distinct test procedures will be discussed in more detail in [Annex A](#).

The “classical” 1-on-1 test is a damage threshold measurement procedure that uses one pulse of laser irradiation on each unexposed test site of the specimen. In contrast, the “classical” S-on-1 measurement program is based on a series of pulses with a constant laser irradiation level applied to each unexposed site of the specimen. Testing with multiple laser pulses is closer to the operational conditions in the field, however, the experimental effort necessary for S-on-1 tests is also significantly higher. The ISO 21254-series also introduce new alternatives – concept of “functional” damage threshold and new testing protocols such as R(S)-on-1 and Raster scan. In an R(S)-on-1 test, the same test site is irradiated with sequences of (S) pulses while gradually increasing the irradiation level between particular irradiations until the damage is observed. As a further extension of this measurement concept, the Raster scan technique is designed to irradiate a significant fraction of the test sample area with spatially overlapping laser pulses. ISO 21254-3 describes the acceptance testing for a certain laser irradiation level of optical surfaces, leaving samples that pass the test undamaged. ISO/TR 21254-4, which considers damage detection methods and the inspection of tested surfaces, is a Technical Report which complements this document.

Lasers and laser-related equipment — Test methods for laser-induced damage threshold —

Part 1: Definitions and general principles

WARNING — Laser exposure of toxic materials (e.g. ZnSe, GaAs, CdTe, ThF₄, chalcogenides, Be, Cr, Ni) can lead to serious health hazards such as toxic fumes.

WARNING — Laser damage threshold testing involves high power lasers, the use of which may come with significant risks, which may include, but are not limited to; eye injury to people; laser burns to people or equipment; ignition of materials; generating debris of toxic materials in the substrate or coating; electrical hazards. It is the responsibility of the user to comply with local guidelines and regulations for their particular set-up.

1 Scope

This document defines terms used in conjunction with, and the general principles of, test methods for determining the laser-induced damage threshold and for the assurance of optical laser components subjected to laser radiation.

2 Normative references

The following documents are referred to in the text in such a way that some or all of their content constitutes requirements of this document. For dated references, only the edition cited applies. For undated references, the latest edition of the referenced document (including any amendments) applies.

ISO 11145, *Optics and photonics — Lasers and laser-related equipment — Vocabulary and symbols*

ISO 11146-1, *Lasers and laser-related equipment — Test methods for laser beam widths, divergence angles and beam propagation ratios — Part 1: Stigmatic and simple astigmatic beams*

ISO 11146-2, *Lasers and laser-related equipment — Test methods for laser beam widths, divergence angles and beam propagation ratios — Part 2: General astigmatic beams*

ISO 21254-2, *Lasers and laser-related equipment — Test methods for laser-induced damage threshold — Part 2: Threshold determination*

ISO 21254-3, *Lasers and laser-related equipment — Test methods for laser-induced damage threshold — Part 3: Assurance of laser power (energy) handling capabilities*

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